

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of

Petrus Antonius VAN NIJNATTEN

Serial No. 10/563,862

Filed: May 12, 2006

Atty. Ref.: 1328-26

TC/A.U.: 1775

Examiner: Unknown

For: EMISSION ENHANCING COATING, ARTICLE TO WHICH THE COATING IS APPLIED, AND METHOD FOR APPLYING THE COATING TO A SURFACE

February 23, 2007

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is invited to the attached copy of an International Search Report in the underlying Dutch application and a copy of each non-U.S. patent document cited in it. A completed Form PTO/SB/08A is also attached.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO/SB/08A with the examiner's initials in the left column [MPEP §609] with the next communication.

The filing of an Information Disclosure Statement shall not be construed as a representation that a search has been made, an admission that the information cited is, or is considered to be, material to patentability [37 C.F.R. § 1.97(g) & (h)] or that no other material information exists.

The Commissioner is hereby authorized to charge our Deposit Account No. 14-1140 for any fees required in connection with the filing of this Information Disclosure Statement.

Petrus Antonius VAN NIJNATTEN Serial No. 10/563,862

Respectfully submitted,

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Sheet 1 of 1

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

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Petrus Antonius VAN NIJNATTEN
FILING DATE

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